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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Tsuga et al.

Art Unit: 1746

Serial No.: 10/085,725

Examiner: Kornakov, M.

Filing Date: 02/28/2002

Docket No.: TI-31621

Customer No.: 23494

Conf. No.: 1672

Title: METHOD AND DEVICE FOR REMOVING PARTICLES ON
SEMICONDUCTOR WAFERS

OFFICIAL

REQUEST FOR EXTENSION OF TIMECommissioner of Patents
PO Box 1450
Alexandria, VA 22313-1450

Dear Sir:

CERTIFICATION OF FACSIMILE TRANSMISSION

I hereby certify that the following papers are being transmitted by
facsimile to the U.S. Patent and Trademark Office at 703-872-9306 on
the date shown below.

Jacqueline J. Garner, Reg. No. 36,144

June 21, 2004
Date

Pursuant to 37 CFR 1.136(a), Applicant(s) respectfully petitions the Commissioner for an extension of the shortened statutory period for response in the above-identified Application.

The fee for this extension is indicated below:

- ☐ One Month (\$110)
☒ Two Months (\$420)
☐ Three Months (\$950)
☐ Four Months (\$1,480)

Please charge the fee to deposit account no. 20-0668. Any further necessary extension of time is hereby requested. Charge any and all fees to deposit account no. 20-0668. An original and two copies of this sheet are enclosed.

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Respectfully Submitted,

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